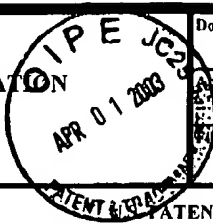


**INFORMATION DISCLOSURE CITATION**  
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Docket Number (Optional)  
03850.010001

Application Number  
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Applicant(s)  
Oliver KIENZLE, et al.

Filing Date  
08/21/2001

Group Art Unit  
1756

**PATENT DOCUMENTS**

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE (IF APPROPRIATE)
len	A1	5,079,112	01/07/1992	Berger et al.	430	4	08/07/1989
	A2	5,130,213	07/14/1992	Berger et al.	430	4	03/23/1990
	A3	5,258,246	11/02/1993	Berger et al.	430	4	07/14/1992
	A4	5,260,151	11/09/1993	Berger et al.	430	5	12/30/1991
	A5	5,316,879	05/31/1994	Berger et al.	430	5	07/14/1992
	A6	5,376,505	12/27/1994	Berger et al.	430	296	03/16/1992
	A7	5,650,629	07/22/1997	Levi	250	491.1	06/28/1994
	A8	5,906,902	05/25/1999	Farrow	430	30	02/26/1997
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**FOREIGN PATENT DOCUMENTS**

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
len	A10	EP 0 953 876 A2	11/03/1999	Europe	<del>G05F</del>	<del>H11F</del>		
len	A11	EP 0 969 326 A2	01/05/2000	Europe	<del>G05F</del>	<del>H20</del>		

**OTHER DOCUMENTS** (Including Author, Title, Date, Pertinent Pages, Etc.).

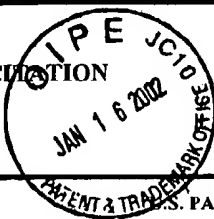
len	A12	J. A Liddle, et al.; "SCALPEL: A Projection Electron-Beam Approach To Sub-Optical Lithography"; 71 pages; Technology Review, December 1999

EXAMINER *len* *MU YEN*

DATE CONSIDERED *11-30-03*

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**03850/010**

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Applicant(s)  
**Oliver KIENZLE et al.**

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**August 21, 2001**

Group Art Unit  
**1756**

**U.S. PATENT DOCUMENTS**

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
len	A1	4,521,711	06/04/1985	Okamoto et al.	310	313 B	04/07/1983
	A2	4,736,172	04/05/1988	Ebneter	333	193	09/02/1985
	A3	4,910,839	03/27/1990	Wright	333	25.35	12/03/1984
	A4	5,073,763	12/17/1991	Wright	333	193	11/02/1990
	A5	5,162,689	11/10/1992	Fliegel et al.	310	313 B	05/01/1991
	A6	5,264,751	11/23/1993	Duffile et al.	310	313 B	09/30/1992
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	A9	5,334,960	08/02/19974	Penunuri	333	193	02/16/1993
	A10	5,353,206	11/15/1994	Machui et al.	333	195	11/14/1990
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**FOREIGN PATENT DOCUMENTS**

REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO

**OTHER DOCUMENTS** (Including Author, Title, Date, Pertinent Pages, Etc.)

	A12	<p>ESRF Annual Report for 1995/1996 located at <a href="http://www.esrf.fr/info/science/annrep/95-96/report/exp/rid32/rid32.htm">http://www.esrf.fr/info/science/annrep/95-96/report/exp/rid32/rid32.htm</a>, 9 pgs/  <i>This is not the prior art.</i></p>					

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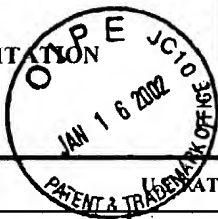
Docket Number (Optional)  
**03850/0100**

Application Number  
**09/934,262**

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**Oliver KIENZLE et al.**

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**August 21, 2001**

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*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
VEN	B1	5,406,159	04/11/1995	Wright	310	313 D	11/11/1993
	B2	5,773,911	06/30/1998	Tanaka et al.	310	313 B	07/29/1997
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	B4	6,033,079	03/07/2000	Hudyma	359	857	03/15/1999
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**FOREIGN PATENT DOCUMENTS**

REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO

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